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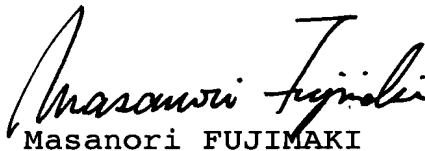
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hereby declare that I am familiar with the English and
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Application, JP 2003-015014.

This 25 day of February, 2008


Masanori FUJIMAKI

PATENT OFFICE
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[Title of the Invention] ELECTRONIC DEVICE, INTEGRATED
ELECTRONIC DEVICE USING THE SAME, AND OPERATION METHOD USING THE
SAME

5 [Claims]

[Claim 1] An electronic device comprising at least a
memory core formed of an alloy serving as an electronic
conductor and an electrode provided on each of both ends of the
memory core, wherein

10 the memory core is formed of an alloy which is a
supersaturated solid-solution before writing or at the time of
data recording and in which phase separation takes place during
temperature increase.

[Claim 2] An electronic device comprising at least a
15 memory core formed of an alloy serving as an electronic
conductor and an electrode provided on each of both ends of the
memory core, wherein

the memory core is formed of an alloy which is a phase
separated mixture before writing or at the time of data
20 recording and in which the formation of a solid-solution takes
place during temperature increase.

[Claim 3] An electronic device comprising at least a
memory core formed of an alloy serving as an electronic
conductor and an electrode provided on each of both ends of the
25 memory core, wherein

the memory core is formed of an alloy which is a compound
before writing or at the time of data recording and which
includes a component in which phase separation can take place

during temperature increase.

[Claim 4] An electronic device comprising at least a memory core formed of an alloy serving as an electronic conductor and an electrode provided on each of both ends of the
5 memory core, wherein

the memory core is formed of an alloy which is a phase separated mixture before writing or at the time of data recording and in which a compound is generated during temperature increase.

10 [Claim 5] An electronic device comprising at least a memory core formed of an alloy serving as an electronic conductor and an electrode provided on each of both ends of the memory core, wherein

the memory core is formed of an alloy which is an
15 amorphous material before writing or at the time of data recording and in which crystallization takes place during temperature increase.

[Claim 6] An electronic device comprising at least a memory core formed of an alloy serving as an electronic
20 conductor and an electrode provided on each of both ends of the memory core, wherein

the memory core is formed of an alloy which is a compound before writing or at the time of data recording and which includes a component in which a phase transition to another
25 crystal phase having the same composition takes place during temperature increase.

[Claim 7] An electronic device comprising at least a memory core formed of an alloy serving as an electronic

conductor and an electrode provided on each of both ends of the memory core, wherein

the memory core is formed of an alloy which is a supersaturated solid-solution or a phase separated mixture
5 before writing or at the time of data recording and in which spinodal decomposition or the formation of a solid-solution which is the inverse process can take place during temperature increase.

8. An electronic device comprising at least a memory core
10 formed of an alloy serving as an electronic conductor and an electrode provided on each of both ends of the memory core, wherein

the memory core is formed of an alloy which is a compound or a phase separated mixture before writing or at the time of
15 data recording and in which martensitic transformation can take place during temperature increase.

[Claim 9] An electronic device comprising at least a memory core formed of an alloy serving as an electronic conductor and an electrode provided on each of both ends of the
20 memory core, wherein

the memory core is formed of an alloy which is in a crystallographically stable state before writing or at the time of data recording and in which a non-equilibrium state accompanying with a solid-solid phase transition can be achieved
25 during temperature increase.

[Claim 10] An electronic device comprising at least a memory core formed of an alloy serving as an electronic conductor and an electrode provided on each of both ends of the

memory core, wherein

the memory core is formed of an alloy which is in a crystallographically metastable state before writing or at the time of data recording and in which a non-equilibrium state
5 accompanying with a solid-solid phase transition can be achieved during temperature increase.

[Claim 11] The electronic device according to any one of claims 1 to 10, wherein

at least one of the electrodes connected to the memory
10 core is formed of a semiconductor also having a function for detecting junction resistance.

[Claim 12] The electronic device according to any one of claims 1 to 10, comprising a third electrode directly connected to the memory core or a third electrode positioned in close
15 proximity of the memory core and insulated from the memory core, the third electrode for detecting a junction resistance, resistance, an electric potential, or an electric capacity.

[Claim 13] The electronic device according to any one of claims 1 to 12, wherein

20 an interface between the memory core and the electrode directly connected with the memory core has a chemical potential adjusting layer having a thickness of at least 0.1 monolayers or more.

[Claim 14] The electronic device according to any one of
25 claims 1 to 13, wherein

the composition of the alloy forming the electronic device is caused to be biased by supplying an electric current to the electronic device to thereby write data on the electronic device.

[Claim 15] An integrated electronic device, wherein: a plurality of the electronic devices according to any one of claims 1 to 14 are arranged in rows and columns; the electrode connected to one of both the ends of the memory core serves as a word line; the electrode selected from among the other electrodes of the memory core and directly provided on the memory core serves as at least a bit line; and writing-reading operation to the electronic device is achieved by selecting a word line and a bit line to access a certain electronic device of the plurality of electronic devices arranged in rows and columns.

[Claim 16] An operation method for an electronic device comprising at least a memory core formed of an alloy serving as an electronic conductor and an electrode provided on each of both ends of the memory core,

wherein the memory core is formed of an alloy which is a supersaturated solid-solution before writing or at the time of data recording, and a temperature of the memory core is changed such that the supersaturated solid-solution is phase-separated at the time of writing.

[Claim 17] An operation method for an electronic device comprising at least a memory core formed of an alloy serving as an electronic conductor and an electrode provided on each of both ends of the memory core,

wherein the memory core is formed of an alloy which is a phase separated mixture before writing or at the time of data recording, and a temperature of the memory core is changed such that the phase separated mixture is allowed to form a solid-

solution at the time of writing.

[Claim 18] An operation method for an electronic device comprising at least a memory core formed of an alloy serving as an electronic conductor and an electrode provided on each of
5 both ends of the memory core,

wherein the memory core is formed of an alloy having a component which is a compound before writing or at the time of data recording, and the temperature of the memory core is changed such that the compound is allowed to phase-separate at
10 the time of writing.

[Claim 19] An operation method for an electronic device comprising at least a memory core formed of an alloy serving as an electronic conductor and an electrode provided on each of both ends of the memory core,

15 wherein the memory core is formed of an alloy which is a phase separated mixture before writing or at the time of data recording, and the temperature of the memory core is changed such that the phase separated mixture is allowed to generate a compound at the time of writing.

20 [Claim 20] An operation method for an electronic device comprising at least a memory core formed of an alloy serving as an electronic conductor and an electrode provided on each of both ends of the memory core,

wherein the memory core is formed of an alloy which is an
25 amorphous material before writing or at the time of data recording, and the temperature of the memory core is changed such that the amorphous material is allowed to crystallize at the time of writing.

[Claim 21] An operation method for an electronic device comprising at least a memory core formed of an alloy serving as an electronic conductor and an electrode provided on each of both ends of the memory core,

5 wherein the memory core is formed of an alloy having a component which is a compound before writing or at the time of data recording, and the temperature of the memory core is changed such that a phase transition of the compound to another crystal phase having the same composition is allowed to take
10 place at the time of writing.

[Claim 22] An operation method for an electronic device comprising at least a memory core formed of an alloy serving as an electronic conductor and an electrode provided on each of both ends of the memory core,

15 wherein the memory core is formed of an alloy which is a supersaturated solid-solution or a phase-separated mixture before writing or at the time of data recording, and the temperature of the memory core is changed such that the supersaturated solid-solution or the phase-separated mixture is
20 allowed to spinodally-decompose or form a solid-solution which is the inverse process thereof at the time of writing.

[Claim 23] An operation method for an electronic device comprising at least a memory core formed of an alloy serving as an electronic conductor and an electrode provided on each of
25 both ends of the memory core,

 wherein the memory core is formed of an alloy which is a compound or a phase separated mixture before writing or at the time of data recording, and the temperature of the memory core

is changed such that martensitic transformation of the compound or the phase separated mixture is allowed to take place at the time of writing.

[Claim 24] An operation method for an electronic device
5 comprising at least a memory core formed of an alloy serving as an electronic conductor and an electrode provided on each of both ends of the memory core,

wherein the memory core is formed of an alloy which is in a crystallographically stable state before writing or at the
10 time of data recording, and the temperature of the memory core is changed such that the alloy is allowed to be in a non-equilibrium state accompanying with a solid-solid phase transition at the time of writing.

[Claim 25] An operation method for an electronic device
15 comprising at least a memory core formed of an alloy serving as an electronic conductor and an electrode provided on each of both ends of the memory core,

wherein the memory core is formed of an alloy which is in a crystallographically metastable state before writing or at the
20 time of data recording, and the temperature of the memory core is changed such that the alloy is allowed to be in a non-equilibrium state accompanying with a solid-solid phase transition at the time of writing.

[Claim 26] The operation method according to any one of
25 claims 16 to 25, wherein

the composition of the alloy forming the electronic device is caused to be biased by supplying an electric current to the electronic device to thereby write data on the electronic device.

[DETAILED DESCRIPTION OF THE INVENTION]

[0001]

[TECHNICAL FIELD OF THE INVENTION]

The present invention relates to an electronic device and
5 a recording method employing the same. In particular, the
present invention relates to an electronic device employing a
memory core made of a material in which electromigration takes
place upon supplying an electric current, and which changes the
composition ratio of at least a part of the element of the
10 material or the shape of the material, and to a recording method
using the electronic device.

[0002]

[PRIOR ART]

Conventionally, in an image recording medium and a
15 recording-reproducing apparatus using the same, and the like, a
video tape, a digital versatile disk, and a hard disk have been
employed. Also, in a music recording medium and a recording-
reproducing apparatus using the same, a magnetic tape, a
writable compact disk, a flash memory (floating-gate
20 transistors), and the like have been employed. Further, a floppy
disk, a hard disk, a digital versatile disk, a writable compact
disk, a flash memory, and a ferroelectric memory have been
employed for storing data in a computer or the like.

[0003]

25 A memory apparatus of a writable type that can maintain
stored data after power is shut-off is classified according to a
writing method into an apparatus of a type in which a recording
medium is scanned or rotated, such as a magnetic recording

apparatus, a magneto-optic recording apparatus, and a phase change recording apparatus, and an apparatus of a matrix type in which mechanical scanning or rotation is not required, such as a semiconductor memory and a ferroelectric memory.

5 [0004]

The following devices have been known, but they have not been practical for use. Patent Document 1 discloses a memory apparatus which utilizes atomic or molecular electrophoresis or an electrochemical reaction in an ionic conductive material (an
10 electrolyte). Patent Document 2 discloses a phase change memory which utilizes the characteristics of phase change of chalcogenide caused by a temperature change. Further, in Patent Document 3, a device which utilizes a metal ion precipitating phenomenon in chalcogenide serving as an ionic conductive
15 material has been proposed. However, in the above patent, the ionic migration principle is misidentified or misdescribed as electromigration.

[0005]

An device which was recognized to utilize electromigration,
20 or the basis of the present invention, includes the electronic device disclosed in Patent Document 4 and that disclosed in Patent Document 5 which seems to be practical.

[0006]

[Patent Documents 1]

25 Japanese Patent Laid-Open Publication No. Hei 6-28841(Page 4, column 0023, Figs 1 and 2)

[Patent Documents 2]

United States Patent No. 3,271,591(Column 14, Fig.1)

[Patent Documents 3]

United States Patent No. 5,363,329(Column 3, lines 39, 59)

[Patent Documents 4]

Japanese Patent Laid-Open Publication No. Hei 08-293585(Page 16,
5 columns 75 and 76, Fig. 8)

[Patent Documents 5]

Japanese Patent Laid-Open Publication No. 2001-267513(Pages 6
and 7, Column 30 to 32, Fig. 1)

[0007]

10 [Problem to be solved by the Invention]

In a recording-reproducing apparatus of a type which
requires scanning or rotation of the above described recording
mediums, a mechanically movable portion must be provided, and
the limit of size and weight reduction has already been reached.
15 The mechanical shock resistance thereof is low, and the writing
and reading speed is significantly slowed by the time required
to move to the recording position on the medium.

[0008]

A semiconductor memory apparatus such as a flush memory
20 requires complicated production steps, and the cost is high.
Therefore, a semiconductor memory apparatus having a large
storage capacity comparable to that of a magnetic recording
apparatus has not been widely used in practice. Further, a
ferroelectric memory having a large storage capacity comparable
25 to that of a magnetic recording apparatus is unlikely to be
implemented due to the relatively complicated structure thereof.

[0009]

A memory apparatus utilizing an electrochemical reaction

of an electrolyte has a slow reading-writing speed since a response delay with respect to a high frequency wave or a short-time pulse (caused by a charge accumulation time due to an electric capacity and molecular polarization) always takes place in an ionic conductive material. In addition, the choice of the material which contacts with a chemically active ionic conductive material is limited. Particularly, in order to ensure long-term reliability, a noble metal, a refractory metal, or the like must be employed as an electrode material. Despite this, the long-term durability of the device is still inadequate.

[0010]

The above Patent Document 4 discloses a nonvolatile memory device utilizing so-called electromigration. In this case, an alloy composition is biased through supplying an electric current to the alloy serving as an electronic conductor. However, even if the materials, the devices, and the recording methods disclosed in the above publication are fully utilized, the nonvolatile memory device is still far from practical use. Because the wiring structure which is formed of an aluminum alloy and a tungsten electrode (a plug) disclosed in the above publication is a wiring structure commonly employed in an LSI. Also, the detailed reliability tests for this wiring structure have been repeatedly performed at various temperatures. In this technical field, it is well known that the resistance increase caused by electromigration in the LSI wiring does not take place uniformly, but takes place highly non-uniformly. Therefore, the technology disclosed in the above publication cannot be employed for simultaneous change of a large number of devices with high

reproducibility.

[0011]

The rate of the change caused by electromigration is roughly proportional to the diffusion coefficient of a material and current density. The self-diffusion coefficient of aluminum is approximately 2×10^{-23} m²/s at 200°C according to the article of H. Mehrer, Landolt-Bornstein New Series III/26 (Springer-Verlag, 1990), and the diffusion coefficient of foreign atoms in aluminum does not exceed ten times of the self-diffusion coefficient of aluminum. Since the diffusion coefficient at 200°C is approximately ten times larger than that at 80°C, the void generation time at a current density of 1×10^{10} A/m², which was employed at the time of writing in the above Patent Document 4, can be estimated to be approximately 1×10^7 s by use of the experimental value (a void formation time at a temperature of 80°C and a current density of 1×10^9 A/m² is approximately 1×10^9 s) obtained by S. Vaidya, et al. (Appl. Phys. Lett. 36, 464 (1980)). Assuming that only a very small amount of Si precipitation (a layer thickness of 1 nm = 1/1,000 of a thickness of a void formation region of 1,000 nm) is required and the diffusion coefficient of Si is ten times larger, the writing rate can be estimated to be 1,000 s/bit. Therefore, if the structure and the method disclosed in the Patent Document 4 are merely employed, the required time for writing is 15 minutes per bit, clearly showing impracticality.

[0012]

A feasible technique for a device utilizing electromigration has been disclosed in Patent Document 5. In

this case, to solve the above problems, an alloy which has not been employed in an LSI has been employed, and an electrode for detecting atomic segregation is provided. The above publication also discloses that the temperature of the device itself is
5 caused to increase or the device is caused to melt through the Joule heat generated by the electric current fed to the device to thereby allow electromigration to take place at a fast rate.

[0013]

However, an increase in the rate of the change only by the
10 increase in the device temperature is limited. If the device is caused to melt, the rate of the change significantly increases. However, the reaction with a contacting material is difficult to control, and thus the choice of an electrode material is strongly restricted. There is an increasing demand for
15 developing a material in which segregation takes place at a sufficiently fast rate and re-writing is facilitated without melting the device. However, such a material has not been proposed in Patent Document 5.

[0014]

20 An object of the present invention is to provide a device and an operating method based on the new policy and a concept of the selection of the material, in the manufacturing of the electronic device utilizing electromigration and having a larger storage capacity and a faster reading-writing speed than those
25 of a magnetic recording apparatus, a low manufacturing cost, and compactness comparable to that of a semiconductor memory.

[0015]

Incidentally, in the Patent Document 5, an In-Au alloy and

an Sn-Ni alloy or an Sn (75 at.%) - Ni (25 at.%) alloy are disclosed. In each of these exemplary alloys, the alloy composition is not limited. Even if the alloy composition is disclosed, the non-equilibrium state and the metastable state of a solid phase utilized in the present invention described hereinbelow cannot be employed at the disclosed alloy composition. In the invention disclosed in the Patent Document 5, a concept for utilizing the non-equilibrium state or the metastable state of a solid phase is totally absent.

10 [0016]

[MEANS FOR SOLVING THE PROBLEM]

A first aspect of the present invention comprises at least a memory core formed of an alloy serving as an electronic conductor and an electrode provided on each of both ends of the memory core.

An electronic device has a memory core formed of an alloy which is a supersaturated solid-solution before writing or at the time of data recording and in which phase separation can take place during temperature increase.

20 Or an electronic device has a memory core formed of an alloy which is a phase separated mixture before writing or at the time of data recording and in which the formation of a solid-solution can take place during temperature increase.

Or an electronic device has a memory core formed of an alloy which is a compound before writing or at the time of data recording and which includes a component in which phase separation can take place during temperature increase.

Or an electronic device has a memory core formed of an

alloy which is a phase separated mixture before writing or at the time of data recording and in which a compound can be generated during temperature increase.

Or an electronic device has a memory core formed of an alloy which is an amorphous material before writing or at the time of data recording and in which crystallization can take place during temperature increase.

Or an electronic device has a memory core formed of an alloy which is a compound before writing or at the time of data recording and which includes a component in which a phase transition to another crystal phase having the same composition can take place during temperature increase.

Or an electronic device has a memory core formed of an alloy which is a supersaturated solid-solution or a phase separated mixture before writing or at the time of data recording and in which spinodal decomposition or the formation of a solid-solution which is the inverse process can take place during temperature increase.

Or an electronic device has a memory core formed of an alloy which is a compound or a phase separated mixture before writing or at the time of data recording and in which martensitic transformation can take place during temperature increase.

Or an electronic device has a memory core formed of an alloy which is in a crystallographically stable state before writing or at the time of data recording and in which a non-equilibrium state accompanying with a solid-solid phase transition can be achieved during temperature increase.

Or an electronic device has a memory core formed of an alloy which is in a crystallographically metastable state before writing or at the time of data recording and in which a non-equilibrium state accompanying with a solid-solid phase
5 transition can be achieved during temperature increase.

[0017]

In each of the above electronic devices, at least one of the electrodes connected to the memory core is formed of a semiconductor also having a function for detecting a junction
10 resistance.

or, the above electronic devices comprise a third electrode directly connected to the memory core or a third electrode positioned in close proximity of the memory core and insulated from the memory core, the third electrode for
15 detecting a junction resistance, resistance, an electric potential, or an electric capacity.

[0018]

Further, in the above electronic devices, an interface between the memory core and the electrode directly connected
20 with the memory core preferably has a chemical potential adjusting layer having a thickness of at least 0.1 monolayers or more.

[0019]

In the above electronic devices, the composition of the alloy forming the electronic device is caused to be biased by
25 supplying an electric current to the electronic device to thereby write data on the electronic device.

[0020]

A second aspect of the present invention is an integrated electronic device, wherein: a plurality of the above electronic devices are arranged in rows and columns; the electrode connected to one of both the ends of the memory core serves as a word line; the electrode selected from among the other electrodes of the memory core and directly provided on the memory core serves as at least a bit line; and writing-reading operation to the electronic device is achieved by selecting a word line and a bit line to access a certain electronic device of the plurality of electronic devices arranged in rows and columns.

[0021]

A third aspect of the present invention is an operation method for an electronic device comprising at least a memory core formed of an alloy serving as an electronic conductor and an electrode provided on each of both ends of the memory core. In the operating method, the memory core is formed of an alloy which is a supersaturated solid-solution before writing or at the time of data recording, and a temperature of the memory core is changed such that the supersaturated solid-solution is phase-separated at the time of writing.

Or in an operation method, the memory core is formed of an alloy which is a phase separated mixture before writing or at the time of data recording, and a temperature of the memory core is changed such that the phase separated mixture is allowed to form a solid-solution at the time of writing.

Or in an operation method, the memory core is formed of an alloy having a component which is a compound before writing or

at the time of data recording, and the temperature of the memory core is changed such that the compound is allowed to phase-separate at the time of writing.

Or in an operation method, the memory core is formed of an alloy which is a phase separated mixture before writing or at the time of data recording, and the temperature of the memory core is changed such that the phase separated mixture is allowed to generate a compound at the time of writing.

Or in an operation method, the memory core is formed of an alloy which is an amorphous material before writing or at the time of data recording, and the temperature of the memory core is changed such that the amorphous material is allowed to crystallize at the time of writing.

Or in an operation method, the memory core is formed of an alloy having a component which is a compound before writing or at the time of data recording, and the temperature of the memory core is changed such that a phase transition of the compound to another crystal phase having the same composition is allowed to take place at the time of writing.

Or in an operation method, the memory core is formed of an alloy which is a supersaturated solid-solution or a phase-separated mixture before writing or at the time of data recording, and the temperature of the memory core is changed such that the supersaturated solid-solution or the phase-separated mixture is allowed to spinodally-decompose or form a solid-solution which is the inverse process thereof at the time of writing.

Or in an operation method, the memory core is formed of an

alloy which is a compound or a phase separated mixture before writing or at the time of data recording, and the temperature of the memory core is changed such that martensitic transformation of the compound or the phase separated mixture is allowed to
5 take place at the time of writing.

Or in an operation method, the memory core is formed of an alloy which is in a crystallographically stable state before writing or at the time of data recording, and the temperature of the memory core is changed such that the alloy is allowed to be
10 in a non-equilibrium state accompanying with a solid-solid phase transition at the time of writing.

Or in an operation method, the memory core is formed of an alloy which is in a crystallographically metastable state before writing or at the time of data recording, and the temperature of
15 the memory core is changed such that the alloy is allowed to be in a non-equilibrium state accompanying with a solid-solid phase transition at the time of writing.

[0022]

In the above operation methods, the composition of the
20 alloy forming the electronic device is caused to be biased by supplying an electric current to the electronic device to thereby write data on the electronic device.

[0023]

The fundamental feature of the present invention is to
25 operate an electronic device at a fast speed through utilizing electromigration which takes place at a very fast rate in a non-equilibrium state during a phase transition from a stable state or a metastable state to thereby ensure stable writing or re-

writing operation.

[0024]

A phase change memory is a known technique and stores the state of a material itself. On the other hand, in the present invention, the state of a material itself is not required to be stored, and also the memory material state to be stored is not required to be two or more. Any material, including a material which recovers the original state (phase) after writing operation, may be employed so long as a phase transition takes place at the instant of writing.

[0025]

In the present application, the metastable state shall refer to a non-equilibrium state having a very long life and accompanied with a thermodynamical phase transition. Examples of the metastable state include a supercooled state (including a delay of phase separation and the generation of a compound), a supersaturated state (including a state in which an excessive amount is dissolved in a solid-solution), an amorphous state, and the like. These phenomena are induced by the micro-sizing effects or the surface or interface effects caused by the formation of a thin film or a microprocessing, the formation of an alloy thin film through simultaneous deposition, rapid cooling, or the like. Although, in some cases, a supercooled state, a supersaturated state, and the like caused by rapid cooling and having a long life are classified into a non-equilibrium state in a strict sense, these are classified into a metastable state in the present application.

[0026]

In the present application, a non-equilibrium state shall refer only to a non-equilibrium state which exists in a short period of time during a general phase transition.

[0027]

5 In order to utilize rapid electromigration in the above-described non-equilibrium state, the memory core is required to be formed of a material in which a phase transition takes place at a temperature within the temperature range which includes the temperature of the memory core caused to increase at the time of
10 operation. In a certain material, a phase transition occurs from a thermodynamically stable state through temperature increase, but the kinds of these materials are limited. A metastable state is present in a wide range of alloy systems. If a phase transition from such a metastable state is utilized, the
15 material for the memory device can be selected from a wide variety of materials upon designing the memory device, thereby facilitating the manufacture of the device having the desired characteristics.

[0028]

20 Examples of the phase transition caused by temperature increase include: (1) phase separation from a solid-solution or a supersaturated solid-solution; (2) the formation of a solid-solution from a phase separated mixture; (3) phase separation from a compound; (4) the generation of a compound from a phase
25 separated mixture; (5) crystallization from an amorphous state; (6) a phase transition to another crystal structure having the same composition; (7) spinodal decomposition; and (8) martensitic transformation.

[0029]

A metastable state generated by rapid cooling or a size effect may be employed as the starting state (a state in which a memory device is blank or a storage state) of the phase transition described above.

[0030]

In some cases, a particular configuration for maintaining the metastable state must be provided. For example, a certain supersaturated solid-solution starts phase-separating upon merely contacting with an electrode material to thereby cause segregation in the electrode. In such a material, a layer for adjusting the chemical potential difference on the surface or the interface must be provided on the interface between an electrode and a memory core. Specifically, the chemical potential adjusting layer can be implemented by chemically adsorbing atoms such as hydrogen, halogen, oxygen, and nitrogen on the surface of an electrode or a memory core. The chemical potential adjusting layer on the interface should not act as an insulative film, but any insulative film may be employed as the chemical potential adjusting layer on the interface so long as the insulative film has a thickness thin enough to freely pass electrons therethrough by tunneling conduction. The amount of adsorbed atoms should be approximately 0.1 monolayers or more, when one monolayer is defined as the total number of atomic bonds on the interface. The thickness of the insulative layer should be approximately 2 nm or less for allowing electrons to freely pass through the insulative layer by tunneling conduction.

[0031]

[BEST MODE FOR CARRYING OUT THE INVENTION]

Embodiments of the present invention will next be described in detail with reference to the drawings.

[0032]

5 First, the metastable state and the non-equilibrium state of an alloy, which are the main concept defining the present invention, will be described.

[0033]

Fig. 1 is a schematic binary phase diagram for explaining
10 the concept of the present invention. This binary phase diagram represents an alloy system of a virtual element A and a virtual element B, and the alloy system is a macroscopic system in which the effects of surface and interface can be neglected. As shown in Fig. 1, a solid-solution region 106 of the element B in the
15 element A is represented by an element B atomic concentration 101 and temperature 102. If the micro-sizing effects caused by forming a thin film or microprocessing are applied to the system, an enlarged metastable solid-solution region 107 emerges in Fig. 1. The alloy having a composition within the metastable solid-
20 solution region 107 at room temperature can be employed as a supersaturated solid-solution in which phase separation can take place upon temperature increase. On the other hand, the alloy having a composition within the crystallographically stable A-B phase-separated region 109 and capable of being in the state of
25 the solid-solution region 106 of the element B in the element A or of the metastable solid-solution region 107 upon temperature increase can be employed as an alloy which can form a solid-solution.

[0034]

As in the above alloy system of the virtual element A and the virtual element B, the solid-solution region of the element A in the element B is absent in the macroscopic system. However, if the microsizing effects caused by forming a thin film or microprocessing are applied to the system, a metastable solid-solution region 108 may occasionally emerge as shown in Fig. 1. An alloy in this metastable solid-solution region 108 can be employed as the alloy described above.

[0035]

As a particular example of a phase transition between solid-solution and a phase separated mixture, spinodal decomposition may be employed as in above.

[0036]

Fig. 2 is also a schematic binary phase diagram for explaining the concept of the present invention. The phase diagram shown in Fig. 2 represents an alloy system of a virtual element C and a virtual element D and illustrates an equilibrium state with respect to a sufficiently slow temperature change. In the phase diagram shown in Fig. 2, assume that a compound X 205 is present at a critical temperature T_c 213 and higher temperatures. In this case, a phase separated mixture at room temperature having a composition in which a phase transition to the compound X 205 takes place upon temperature increase can be employed as a phase separated mixture which can generate a compound. Upon a rapid temperature change, a metastable region 210 containing the compound X emerges and is extended from the critical temperature T_c 213 to lower temperatures. In some cases,

this metastable region is extended to room temperature. The metastable compound X can be employed as a compound in which phase separation can take place. Such an extension of the region described above can be metastably caused by microsizing effects.

5 [0037]

Also, in the above alloy system of the virtual element C and the virtual element D, the alloy having a composition in which a metastable state amorphous phase 212 is formed upon a rapid temperature change and in which the amorphous phase 212
10 crystallizes upon temperature increase, as shown in Fig. 2, can be employed as an amorphous material which can crystallize. The amorphous phase 212 may metastably emerge through simultaneous deposition or microsizing effects.

[0038]

15 Further, in the above alloy system of the virtual element C and the virtual element D, a solid-solution region 208 of the virtual element C in the virtual element D is present, as shown in Fig. 2. The alloy having a composition in which a compound Y 206 and the element D are separated at room temperature and in
20 which the separated state changes to the solid-solution of the virtual element C in the virtual element D in region 208 upon temperature increase can be employed as a phase-separated mixture which can form a solid-solution upon temperature increase.

25 [0039]

In some cases, the compound Y 206 is transformed at the critical temperature T_c 213 to a compound Y_a 214 having the same composition through changing the crystal structure. Such a

compound Y 206 is a compound in which the phase transition utilized in the present invention can take place. In addition, martensitic transformation can be utilized as a particular example of the phase transition described above. The martensitic transformation is widely known to occur during quenching-
5 annealing of iron, and the additive atoms move at a fast speed at the instant of the phase transition.

[0040]

A binary alloy has been employed in examples described
10 above, but the alloy is not limited to a binary alloy. A state change caused by temperature change has been described in the above examples, but, in a certain material, a phase transition can be induced through changing, in addition to temperature, pressure, an electric field, a magnetic field, an
15 electromagnetic wave, and the like and the combinations thereof.

[0041]

The necessary condition of the present invention is to produce an electronic device by use of an alloy material which can utilize the above described metastable state and non-
20 equilibrium state, data being written on the electronic device through biasing an alloy composition by means of electromigration.

[0042]

The electronic device illustrated in Fig. 3, which is also
25 described in the Patent Document 5, is a nonvolatile memory device comprising a memory core 301 which is provided on an insulative substrate and is formed of the alloy of the present invention, an electrode A 302 serves also as a sense electrode

directly bonded to one end of the memory core 301, and an
electrode B 303. The electrode A 302 is formed of a highly doped
semiconductor. Just after the formation of the device, diffusing
element atoms in the memory core 301 are uniformly distributed
5 over the memory core 301 without segregation, and this state is
represented as a uniformly distributed diffusing element 304
shown in Fig. 3(a). The data stored in the electronic device of
Fig. 3 is read out through detecting the change of the Schottky
barrier caused by the segregation of the diffusing element as
10 the change of junction resistance of the sense electrode (see
Figs. 3(b) and 3(c)).

[0043]

On the interface between the semiconductor electrode A 302
and the memory core 301, a chemical potential adjusting layer
15 309 on which atoms, such as hydrogen, halogen, oxygen, or
nitrogen, stable on the interface are chemically adsorbed may be
provided to prevent unnecessary initial segregation.

[0044]

At the time of writing to the electronic device, the
20 migration of the diffusing element (304, 306, or 308) must take
place. At at least the instant of the migration, the migration
speed increases by a factor of 100 or more if a phase transition
takes place to bring the memory core 301 into a non-equilibrium
state.

25 [0045]

Figs. 4 and 5 illustrate embodiments of the electronic
device. These embodiments have also been described in the Patent
Document 5. In these examples, a sense electrode 404 or 504 is

provided as a third electrode to read out data through detecting the junction resistance or the electric potential difference. Writing operation is performed in these examples as the same manner in the above example.

5 [0046]

The above embodiments may be formed by employing various materials including inorganic materials and organic materials.

[0047]

10 The characteristics of the above-described materials of the present invention are induced by an operation method of the electronic device. An operation method for utilizing the temperature change of the memory core itself by means of the Joule heat generated by the electric current fed to the memory core during the time of writing will next be described.

15 [0048]

Fig. 6(a) is a schematic graph for explaining the operation of the electronic device of the present invention near a solubility limit. The horizontal axis represents a writing operation elapsed time 601, and the vertical axis represents an electric current 602 and temperature 603. During a short initial period of the writing operation, a device current 605 is fed such that Joule heat is generated to raise device temperature 604 higher than a solubility temperature 606. Subsequently, the device current 605 is controlled such that Joule heat enough to
25 keep the device temperature 604 slightly lower than the solubility temperature 606 is generated. In this manner, once all impurities are caused to dissolve into a solid-solution, the impurities are distributed uniformly. The uniformly distributed

impurity atoms can then segregate at a fast rate to the desired electrode side through electromigration.

[0049]

Fig. 6(b) is a schematic graph for explaining the operation of the electronic device of the present invention near a compound generation temperature. During a short initial period of writing operation, a device current 609 is fed during a very short period of time such that Joule heat is generated to raise device temperature 608 higher than a phase transition temperature 610 of the generation of the compound. Subsequently, the device current is once brought to zero. And then the device current 609 is fed and maintained such that Joule heat enough to keep the device temperature 608 slightly lower than the phase transition temperature 610 is generated. In this manner, once a compound is allowed to generate, impurities are distributed uniformly. The uniformly distributed impurities can then segregate at a fast rate to the desired electrode side through electromigration.

[0050]

In the above examples of the operation, the Joule heat generated in the memory core through the device current is utilized, but a heat source may be provided near the device to control the temperature. In a certain material, a phase transition caused by changing ambient conditions including, in addition to temperature, pressure, an electric field, a magnetic field, an electromagnetic wave, light, and the like and the combinations thereof has similar effects.

[0051]

(Embodiments)

Specific Embodiments of the present invention will be described with reference to the drawings.

[0052]

5 Fig. 7 is an Au-In binary phase diagram illustrating a first embodiment of the present invention. According to BINARY ALLOY PHASE DIAGRAMS 2nd ed. edited by T.B.Massalski (ASM, 1990), Au dissolved in In is undetectable. However, if a thin film having a thickness of 100 nm or less is formed by means of a simultaneous deposition method, a metastable solid-solution region 701 or a solid-solution region (Au dissolves up to 20 at.%) emerges. The metastable solid-solution region 701 is extended or reduced depending on the film thickness. The alloy thin film having a composition within the metastable solid-solution region 701 is easily separated into In_2O_3 and $\text{In}_2\text{Au}_7\text{O}_{21}$ through electromigration. For example, if the memory core is produced from an alloy thin film having an Au concentration of 14 at.% and the state at an initial point 704 of room temperature is brought to a temperature increased point 705 of 140°C through supplying an electric current, the segregation of $\text{In}_2\text{Au}_7\text{O}_{21}$ is caused to take place in a very short period of time at the instant of time in which the temperature passes through a phase separation point 706 which is the boundary of the metastable solid-solution region 701. In this material, $\text{In}_2\text{Au}_7\text{O}_{21}$ can be segregated in either the positive electrode side or the negative electrode side by controlling the magnitude of the electric current. However, once the segregation of $\text{In}_2\text{Au}_7\text{O}_{21}$ is caused to take place, the uniform state cannot be recovered.

Therefore, this material is useful as a material for a write-once device.

[0053]

Fig. 8 is an Au-Bi binary phase diagram illustrating a second embodiment of the present invention. According to BINARY ALLOY PHASE DIAGRAMS 2nd ed. edited by T.B.Massalski (ASM, 1990), a compound $\text{Au}_2\text{Bi}_8\text{O}_2$ is stable only at a temperature of 116°C or higher. However, if a thin film having a thickness of 100 nm is rapidly cooled, a non-equilibrium region 801 containing the compound $\text{Au}_2\text{Bi}_8\text{O}_2$ and extending from 116°C to lower temperatures emerges. The alloy thin film having a composition and a temperature within the non-equilibrium region 801 is separated at a very fast rate into Au_8O_3 and Bi_8O_4 through electromigration. For example, if the state of the thin film is changed from an initial point 805 of room temperature to a temperature increased point 806 of 120°C through supplying an electric current, the compound $\text{Au}_2\text{Bi}_8\text{O}_2$ is generated from the alloy thin film having Au_8O_3 and Bi_8O_4 separated each other at the instant of time in which the temperature reaches the phase transition point 807. In the alloy thin film having a composition of Au_2Bi , once the temperature is increased to 116°C or higher during the time of writing, the compound is uniformly generated over the entire alloy. Subsequently, Bi_8O_4 can be caused to segregate in the desired electrode side through electromigration while the temperature passes through the phase transition point 807 located at 116°C or lower. Therefore, this material is useful as a material for a device writable for any number of times if operated through a predetermined method.

[0054]

Fig. 9 is an Au-Pt binary phase diagram illustrating a third embodiment of the present invention. According to BINARY ALLOY PHASE DIAGRAMS 2nd ed. edited by T.B.Massalski (ASM, 1990),
5 a phase separated mixture region 901 of Au and Pt is present in the lower temperature side, and a solid-solution region 902 of Au and Pt is present in the higher temperature side. Spinodal decomposition occurs in this system, and a spinodal line 903 lies between the phase separated mixture region 901 and the
10 solid-solution region 902. An initial point 904 of room temperature (Pt: 9 at.%) is located below a dotted line drawn through extrapolating the spinodal line 903 illustrated in the phase diagram of Fig. 9 to the low temperature side. If the memory core in the state of the initial point 904 is brought to
15 the state of a temperature increased point 905 of 180°C through supplying an electric current, electromigration takes place at a fast rate while the temperature passes through a phase transition point 906. Thus, Pt can be caused to segregate in the desired electrode side of the memory core when the temperature
20 is returned to room temperature. This material is also useful as a material for a device writable for any number of times.

[0055]

Fig. 10 is an Fe-C binary phase diagram illustrating a fourth embodiment of the present invention. According to BINARY
25 ALLOY PHASE DIAGRAMS 2nd ed. edited by T.B.Massalski (ASM, 1990), a γ -Fe phase region 1001 is present at a C content of approximately 9 at.% or less and a temperature of 740°C or higher, and a phase separated mixture region 1004 of α -Fe 1002

and Fe_3C 1003 is present at a temperature of 740°C or lower. Martensitic transformation takes place at the boundary between the $\gamma\text{-Fe}$ phase region 1001 and the phase separated mixture region 1004. In addition, if the alloy is quenched, the $\gamma\text{-Fe}$ phase is
5 known to be present at room temperature. An initial point 1005 of room temperature (C: 3 at.%) is located in the low temperature side of the phase diagram of Fig. 10. If the memory core in the state of the initial point 1005 is brought to the state of a temperature increased point 1006 of 180°C through
10 supplying an electric current, martensitic transformation takes place through the assistance of a shock of strains caused by electromigration. In this case, electromigration takes place at a fast rate, and Fe_3C can be caused to segregate in the desired electrode side of the memory core. In this material, once
15 writing is performed, the initial state is not recovered so long as the material is heated to 740°C or higher. Therefore, this material is useful as a material for a write-once device which requires long-term reliability.

[0056]

20 A large number of materials, besides the materials in the above embodiments, can be employed as a material for the alloy applicable to the principle of the present invention. The material may be selected in accordance with the characteristics of an electronic device to be produced.

25 [0057]

Fig. 11 shows the unit cell structure of an electronic device (a memory apparatus) of the specific embodiment of the present invention. In this electronic device, an Au_2Bi alloy is

employed in the two terminal device as shown in Fig. 3. The electronic device is produced as follows.

[0058]

First, an electrode A 1102 serving also as a sense
5 electrode made of P-doped amorphous Si is formed on an insulative substrate 1101 made of polycarbonate by means of a sputtering method and a photolithography process, as shown in Fig. 11.

[0059]

10 Subsequently, a memory core 1103 made of an Au-Bi alloy (Au: 66.7 at.%, Bi: 33.3 at.%) is formed by means of a sputtering method and a photolithography process, and a protection insulative film 1104 formed of a polymethylmethacrylate film is grown by means of a spin coating
15 method. A hole for a bit line 1106 connected to the electrode A 1102 is formed by means of a photolithography process, and the bit line 1106 made of Cu is formed by means of a sputtering method and a photolithography process.

[0060]

20 Subsequently, the protection insulative film 1104 is again grown by means of a spin coating method. A hole for an electrode B 1105 is then formed by means of a photolithography process, and the electrode B made of Cu and a word line 1107 are integrally formed by means of a sputtering method and an etching
25 process. Finally, the protection insulative film 1104 is formed by means of a spin coating method to cover the entire surface.

[0061]

If a plurality of the thus-formed electrical devices are

arranged in lows and columns and a decoder circuit, a sense amplifier circuit, and the like are provided in accordance with a method similar to that in an ordinary semiconductor memory apparatus, a memory apparatus employing the electronic device of
5 the present invention can be implemented.

[0062]

In the above electronic device, a process of temporarily increasing the temperature of the memory core 1103 to 116°C or higher by the Joule heat thereof generated through supplying a
10 predetermined electric current and subsequently causing Bi to segregate in the desired electrode side can be repeatedly performed. In order to achieve the temperature of the memory core 1103 to reach the desired temperature by the Joule heat thereof, circumferential materials should be selected and
15 designed through considering thermal diffusion.

[0063]

[EFFECT OF THE INVENTION]

According to the present invention, an electronic device utilizing a principle in which an alloy composition is biased
20 through electromigration can be obtained with the desired characteristics.

[BRIEF DESCRIPTION OF THE DRAWINGS]

[Fig. 1]

Fig. 1 is a schematic binary phase diagram for explaining
25 a concept of an electronic device of the present invention.

[Fig. 2]

Fig. 2 is a schematic binary phase diagram for explaining a concept of the electronic device of the present invention.

[Fig. 3]

Fig. 3 includes schematic cross-sectional views of the main parts of the device for explaining a first embodiment of the electronic device of the present invention.

5 [Fig. 4]

Fig. 4 includes schematic cross-sectional views of the main parts of the device for explaining a second embodiment of the electronic device of the present invention.

[Fig. 5]

10 Fig. 5 includes schematic cross-sectional views of the main parts of the device for explaining a third embodiment of the electronic device of the present invention.

[Fig. 6]

15 Fig. 6 includes (a) a schematic graph for explaining the electronic device of the present invention when the electronic device is operated near a solubility limit, and (b) a graph for explaining the electronic device of the present invention when the electronic device is operated near compound generation temperature.

20 [Fig. 7]

Fig. 7 is an Au-In binary phase diagram illustrating an embodiment of the present invention.

[Fig. 8]

25 Fig. 8 is an Au-Bi binary phase diagram illustrating an embodiment of the present invention.

[Fig. 9]

Fig. 9 is an Au-Pt binary phase diagram illustrating an embodiment of the present invention.

[Fig. 10]

Fig. 10 is an Fe-C binary phase diagram illustrating an embodiment of the present invention.

[Fig. 11]

5 Fig. 11 includes (a) a projected plan view of the unit cell of the electronic device (a memory device) according to an embodiment of the present invention, (b) a projected left-side view of the same, and (c) a projected right-side view of the same.

10 [Description of the Reference numerals]

101 ; atomic concentration (at.%) of element B

102 ; temperature

103 ; melting point of element A

104 ; melting point of element B

15 105 ; eutectic melting point

106 ; solid-solution region of B in A

107 ; enlarged metastable solid-solution region

108 ; emerged metastable solid-solution region

109 ; A-B phase-separated region

20 110 ; liquid phase region

201 ; atomic concentration (at%) of element D

202 ; temperature

203 ; melting point of element C

204 ; melting point of element D

25 205 ; compound X

206 ; compound Y

207 ; solid-solution region of D in C

208 ; solid-solution region of C in D

- 209 ; enlarged metastable solid-solution region
- 210 ; enlarged metastable region containing the compound X
- 211 ; C-Y phase-separated mixture region
- 212 ; amorphous phase
- 5 213 ; critical temperature T_c
- 214 ; compound Ya
- 301 ; memory core
- 302 ; electrode A serves as a sense electrode
- 303 ; electrode B
- 10 304 ; uniformly distributed diffusing element
- 305 ; electric current flowing from the electrode A to the electrode B
- 306 ; diffusing element concentrated on the electrode A side
- 307 ; electric current flowing from the electrode B to the electrode A
- 15 308 ; diffusing element concentrated on the electrode B side
- 401 ; memory core
- 402 ; electrode A
- 403 ; electrode B
- 20 404 ; a direct bonding type sense electrode
- 405 ; uniformly distributed diffusing element
- 406 ; electric current flowing from the electrode A to the electrode B
- 407 ; diffusing element concentrated on the electrode A side
- 25 408 ; electric current flowing from the electrode B to the electrode A
- 409 ; diffusing element concentrated on the electrode B side
- 410 ; chemical potential adjusting layer

501 ; memory core
502 ; electrode A
503 ; electrode B
504 ; sense electrode positioned in close proximity of the memory
5 core
505 ; uniformly distributed diffusing element
506 ; electric current flowing from the electrode A to the
electrode B
507 ; diffusing element concentrated on the electrode A side
10 508 ; electric current flowing from the electrode B to the
electrode A
509 ; diffusing element concentrated on the electrode B side
601 ; time
602 ; electric current
15 603 ; temperature
604 ; device temperature
605 ; device current
606 ; total solubility temperature
607 ; room temperature
20 608 ; device temperature
609 ; device current
610 ; phase transition temperature
701 ; metastable solid-solution region of the thin film having
thickness of 100 nm or less
25 702 ; In_2Au
703 ; In
704 ; an initial point of room temperature of Au ; 14 at. %
705 ; temperature increased point of 140°C of Au ; 14 at. %

- 706 ; separation point
- 801 ; non-equilibrium region containing the enlarged compound Au_2Bi_8
- 802 ; compound Au_2Bi
- 5 803 ; Au
- 804 ; Bi
- 805 ; initial point of room temperature of Bi: 33.3 at.%
- 806 ; temperature increased point of 180°C of Bi: 33.3 at.%
- 807 ; phase transition point
- 10 901 ; phase separated mixture region of Au and Pt
- 902 ; solid-solution region of Au and Pt
- 903 ; spinodal line
- 904 ; initial point of room temperature of Pt: 9 at.%
- 905 ; temperature increased point of 180°C of Pt: 9 at.%
- 15 906 ; phase transition point
- 1001 ; γ -Fe phase region
- 1002 ; α -Fe
- 1003 ; Fe_3C
- 1004 ; phase separated mixture region of α -Fe and Fe_3C
- 20 1005 ; initial point of room temperature of C: 3 at.%
- 1006 ; temperature increased point of 180°C of C: 3 at.%
- 1101 ; insulative substrate
- 1102 ; electrode A
- 1103 ; memory core
- 25 1104 ; protection insulative film
- 1105 ; electrode B
- 1006 ; bit line
- 1107 ; word line

[NAME OF THE DOCUMENT] ABSTRACT

[ABSTRACT]

[OBJECT]

5 An object of the present invention is to provide a memory device which is compact and light weight, low in manufacturing cost, and has a high density and a larger storage capacity.

[MEANS FOR SOLVING THE PROBLEM]

10 In this case, the electronic device operates at a very fast speed by utilizing a metastable state and electromigration which takes place at a very fast rate in a non-equilibrium state during a phase transition, thereby ensuring stable writing or re-writing operation. The metastable state includes a state induced by micro-sizing effects, the effects of surface and interface, or the formation of an alloy thin film through
15 simultaneous deposition or the like and also includes a supersaturated state, and an amorphous state. An electronic device includes at least a memory core formed of an alloy serving as an electronic conductor and an electrode provided on each of both ends of the memory core. Data is written on the
20 electronic device by supplying an electric current to allow the alloy composition to be biased. The memory core is formed of an alloy which is in a crystallographically stable state before writing or at the time of data recording and in which a non-equilibrium state accompanying with a solid-solid phase
25 transition can be achieved during temperature increase.



[Name of Document] DRAWINGS

FIG. 1

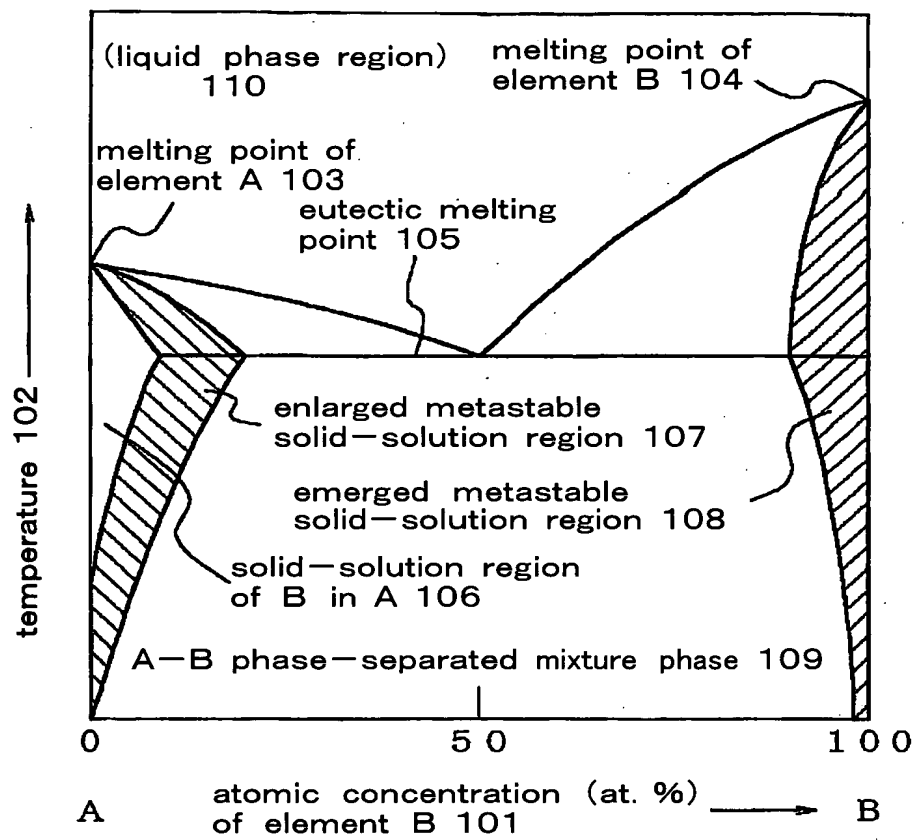


FIG. 2

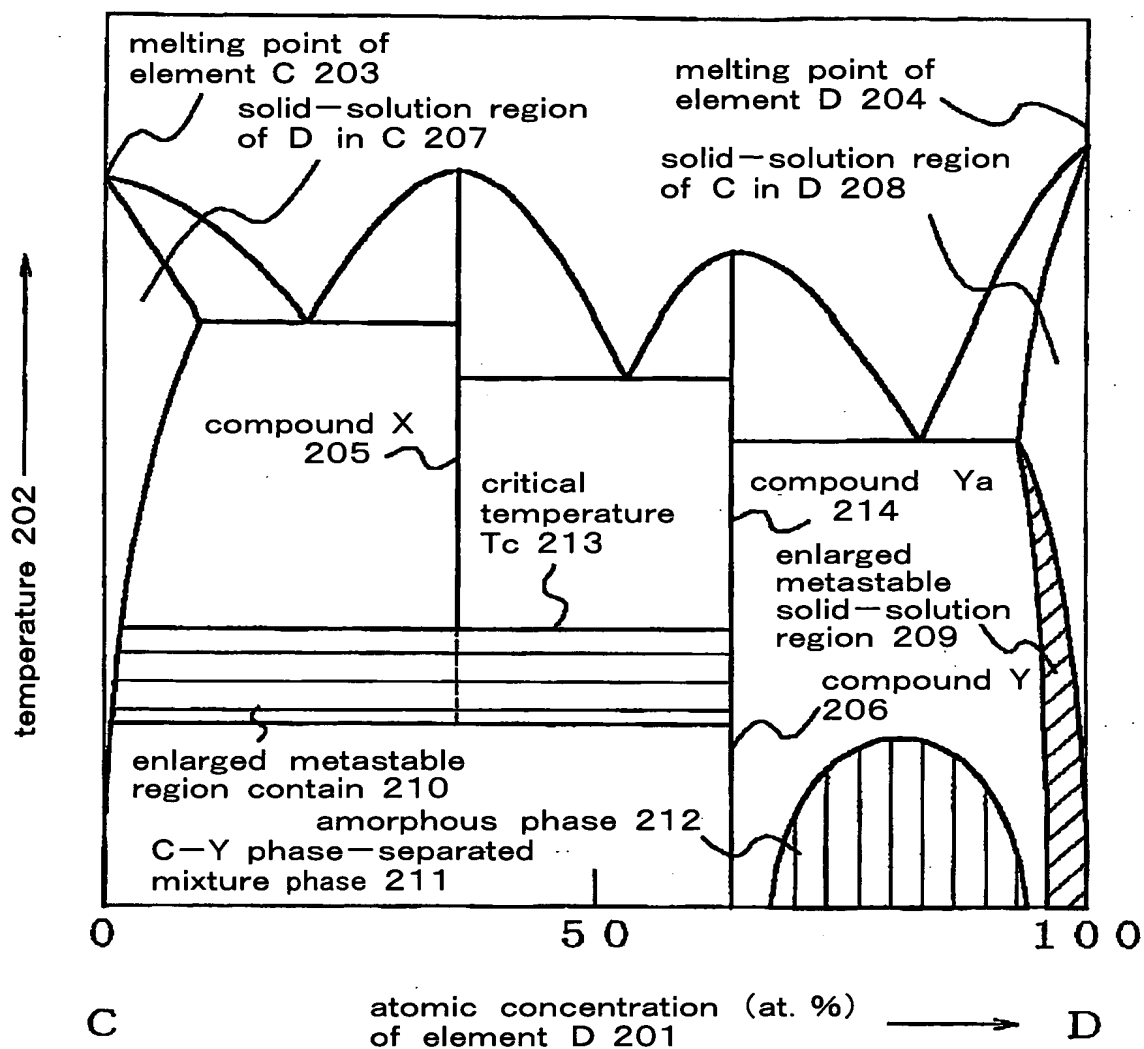
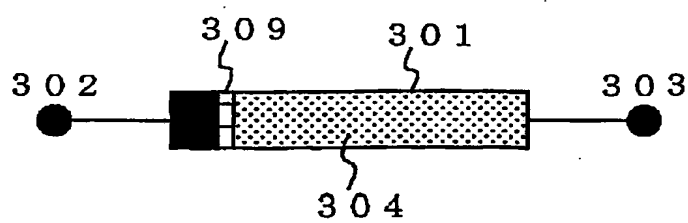
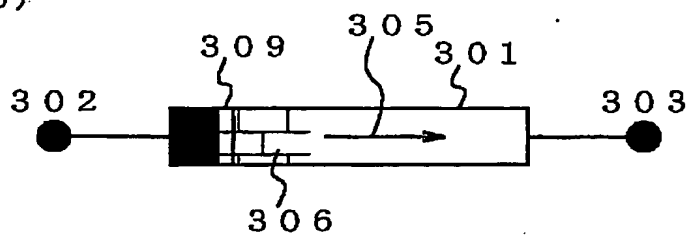


FIG. 3

(a)



(b)



(c)

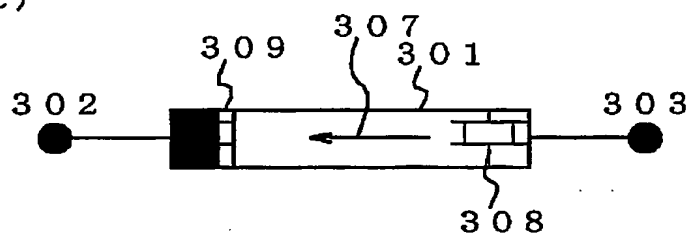


FIG. 4

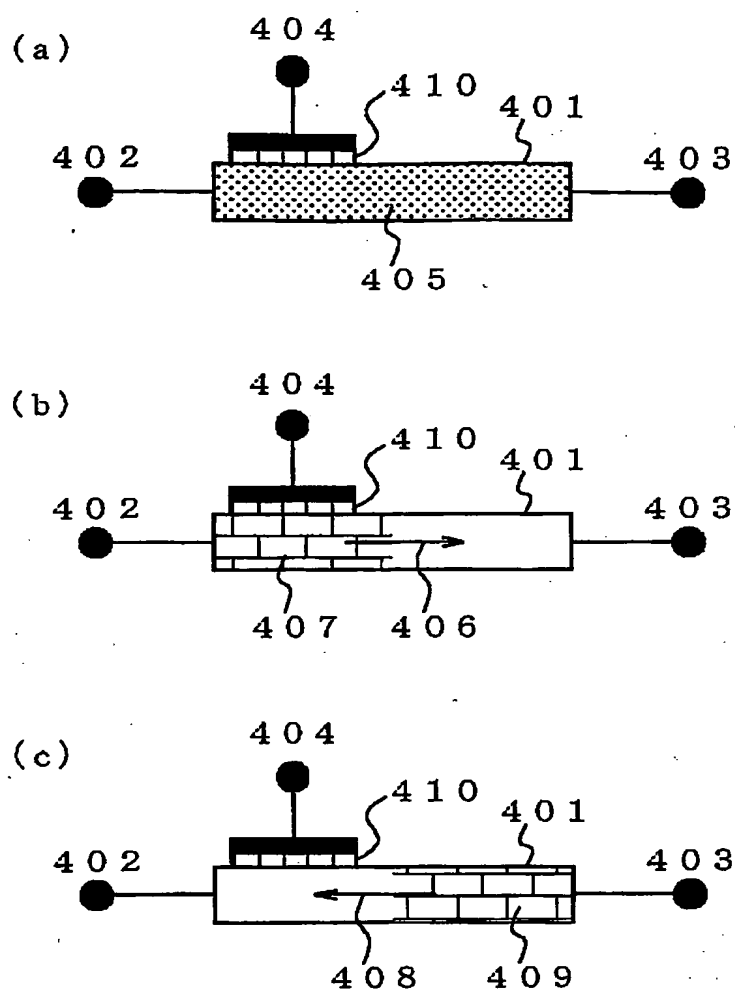


FIG. 5

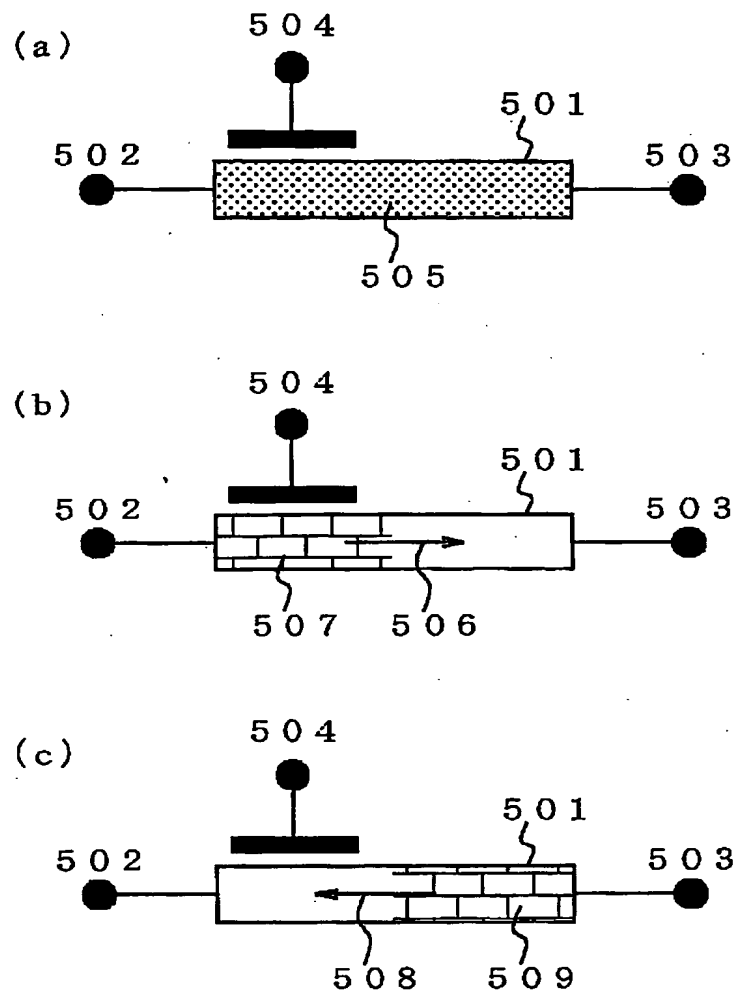


FIG. 6

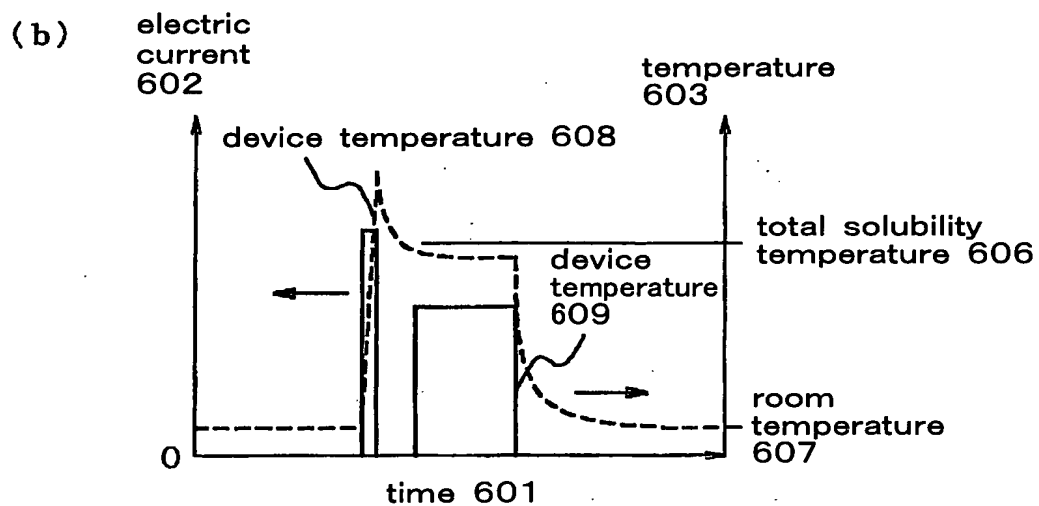
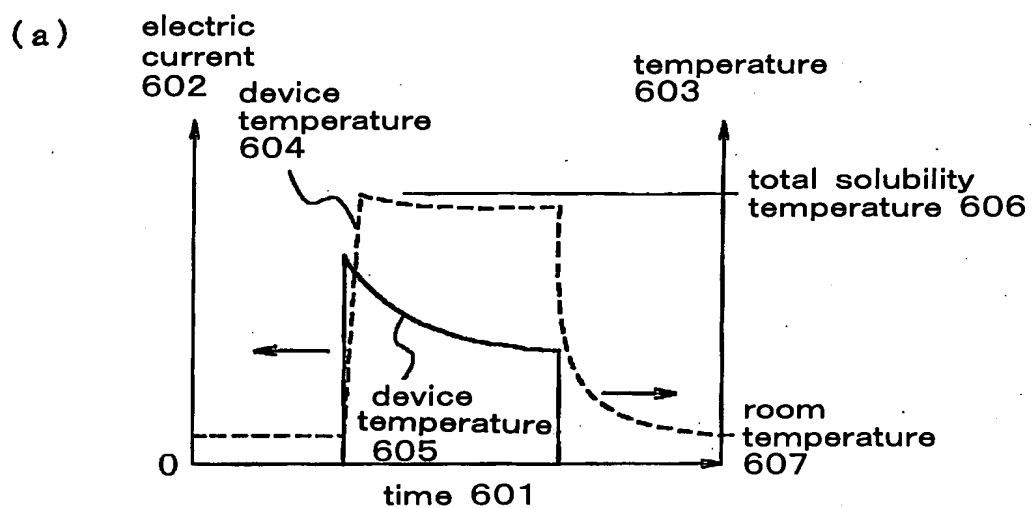


FIG. 7

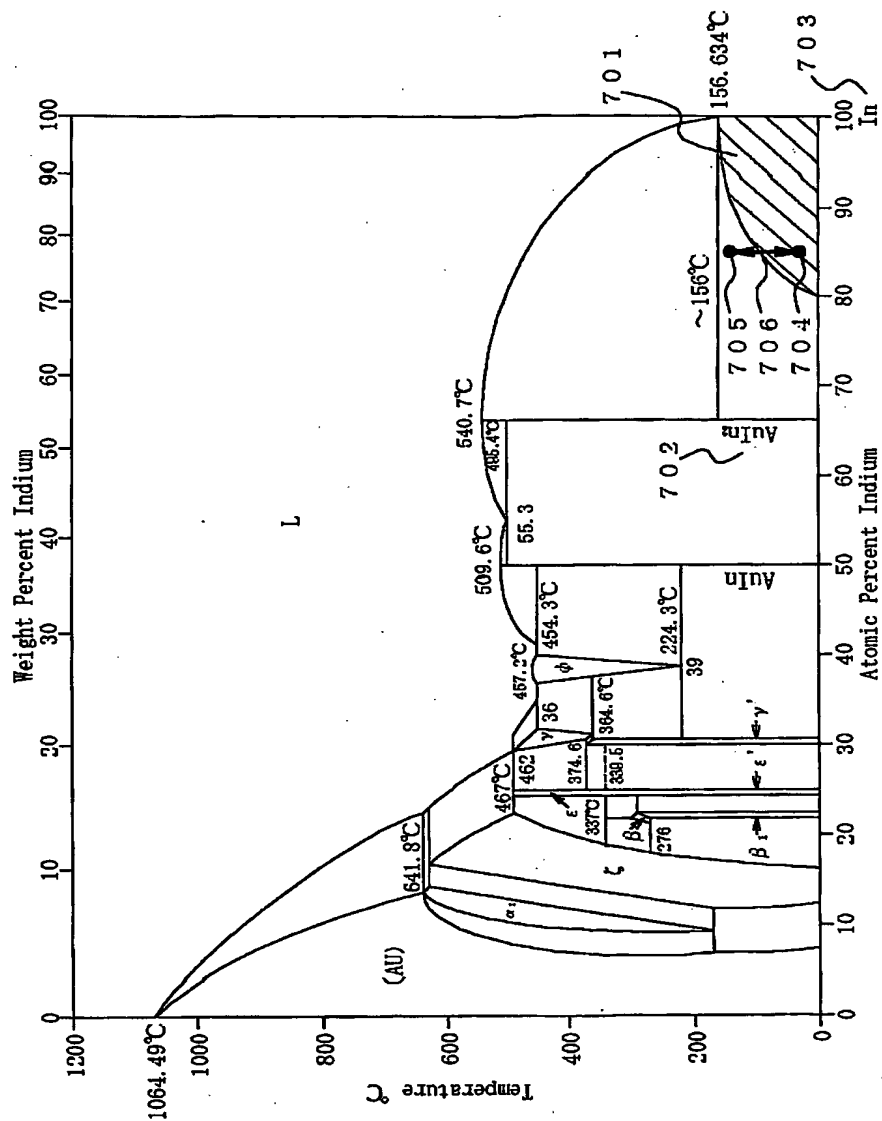


FIG. 8

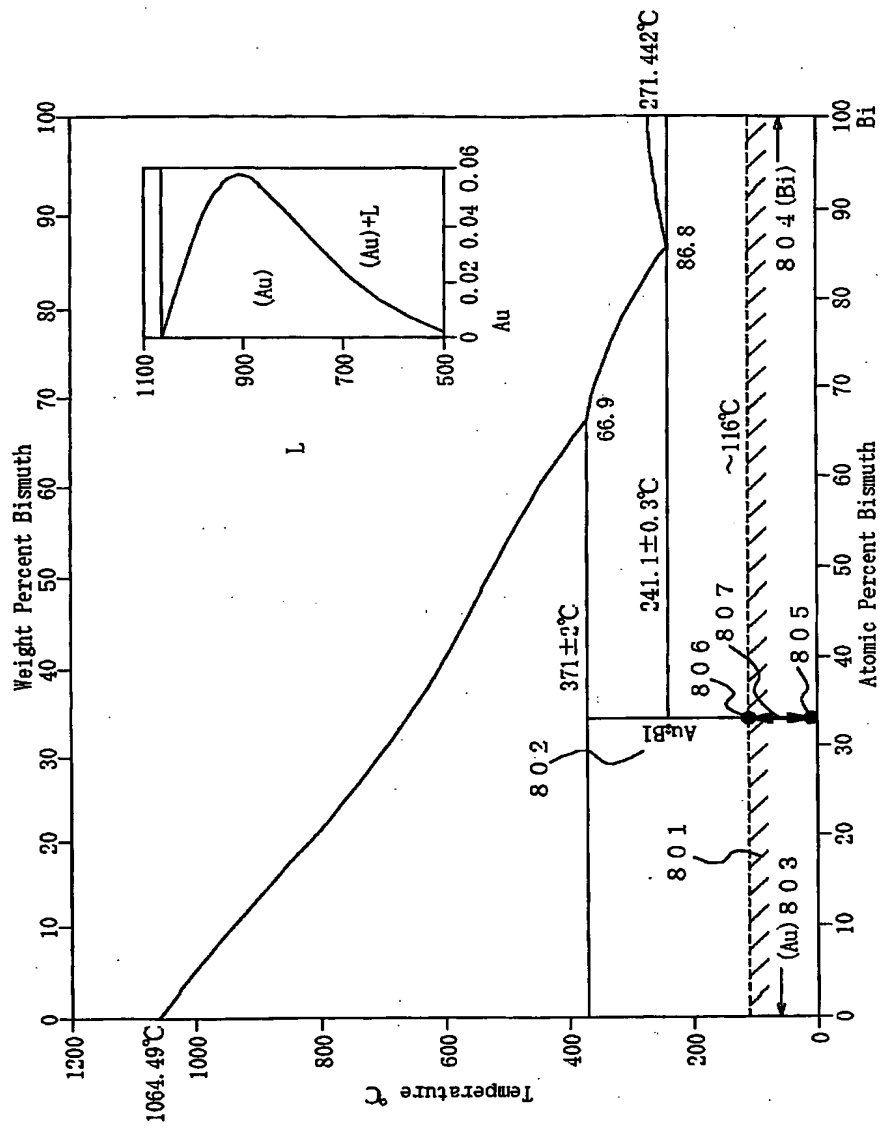


FIG. 9

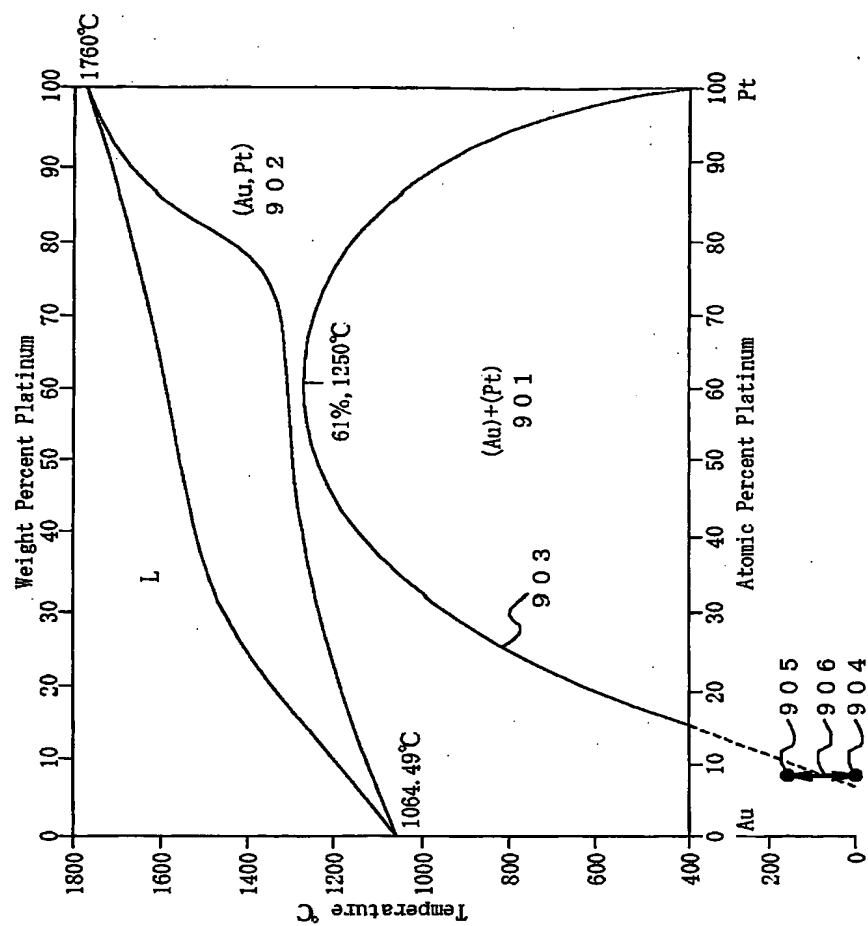


FIG. 10

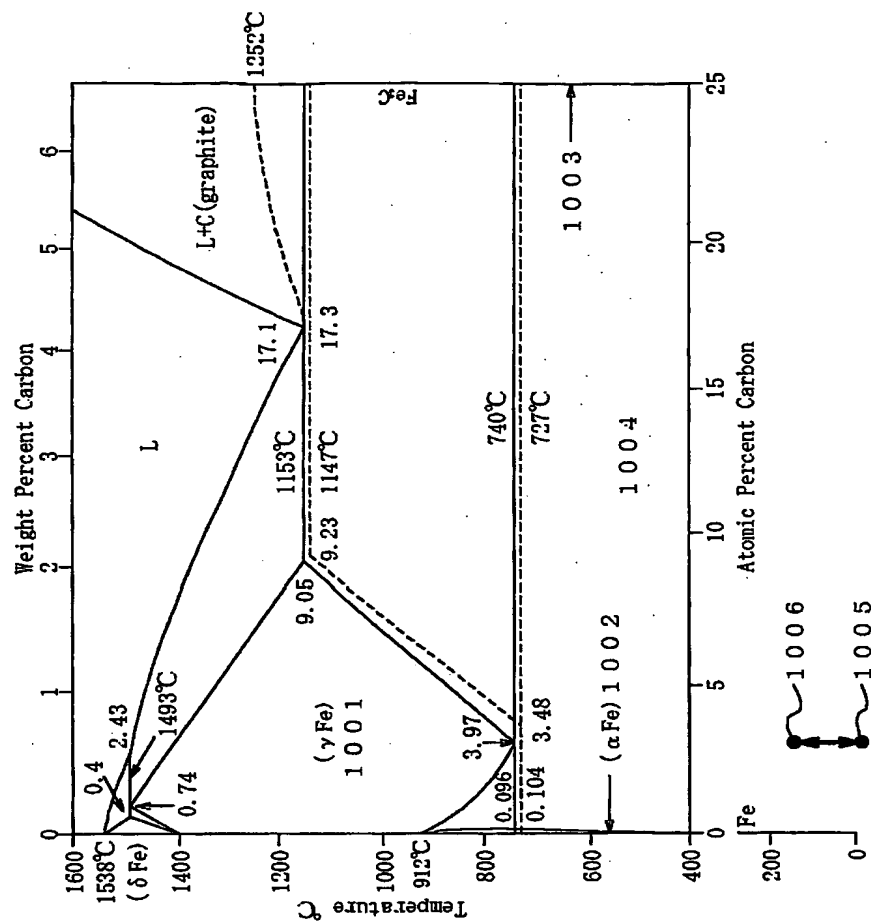


FIG. 11

